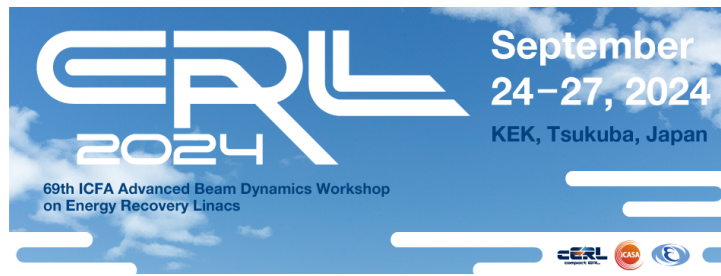


International Workshop on Energy Recovery Linacs (ERL 2024)



Contribution ID: 30

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Accelerator development plan in KEK toward the High-power EUV-FEL light source for future lithography [THO07]

Thursday, 26 September 2024 11:25 (25 minutes)

Presenter: HIROSHI KAWATA (KEK)

Session Classification: WG4 (Applications)